

**TRANSMITTAL OF FORMAL DRAWINGS**Docket No.
SLA0468

Re-Application Of: Apostolos Voutsas, Yukihiko Nakata and Takeshi Hosoda

Serial No.	Filing Date	Batch No.	Examiner	Art Unit
09/696,813	10/25/2000		Khiem D. Nguyen	2823

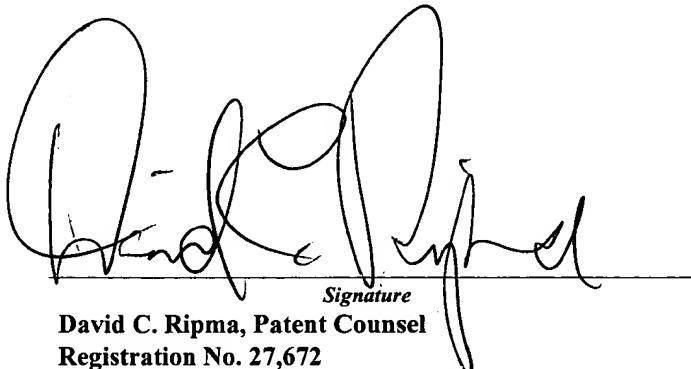
Invention: A Semiconductor Device and a Method of Creating the Same Utilizing Metal Induced Crystallization while Suppressing Partial Solid Phase Crystallization

Address to:
Assistant Commissioner for Patents
Washington, D.C. 20231

Transmitted herewith are:

6 sheets of formal drawing(s) for this application.

Each sheet of drawing indicates the identifying indicia suggested in 37 CFR Section 1.84(c) on the reverse side of the drawing.

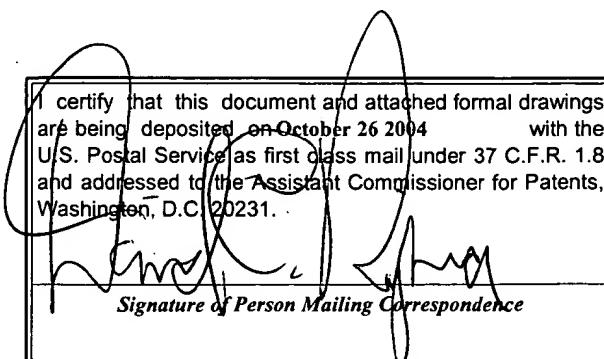


Signature

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Dated: October 26, 2004

I certify that this document and attached formal drawings are being deposited on October 26 2004 with the U.S. Postal Service as first class mail under 37 C.F.R. 1.8 and addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231.



Signature of Person Mailing Correspondence

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